

Docket No.: 265770US26PCT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION: Kiyotaka ISHIBASHI, et al.

SERIAL NO.: 10/524,038

GAU: 1716

FILED: February 9, 2005

EXAMINER: DHINGRA, Rakesh Kumar

FOR: PLASMA PROCESSING DEVICE

**STATEMENT OF SUBSTANCE OF INTERVIEW**

COMMISSIONER FOR PATENTS  
Alexandria, VA 22313

SIR:

Applicants wish to thank the Examiner for the discussion with Applicants' representative, Mr. Kevin M. McKinley, on April 5, 2010, at which time the proposed Examiner's Amendment to amend Claims 1 and 11, and to correct Figures 1 - 3, was authorized.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, L.L.P.



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